Oxygen-free Pd/Ti deposition ICF zero-length NEG pump Information of the paid sample supplying



The ultra-high vacuum pump from Irie Koken

Oxygen-free Pd/Ti deposition ICF 203 zero-length NEG pump

General information

This device serves as an exhaust pump capable of attaining an exceptionally low pressure of 10^{-8} Pa or less when employed in tandem with dry pumps and turbo molecular pumps for vacuum exhaust and baking purposes. The exhaust procedure is initiated through baking at temperatures within the range of 125 to 175°C, with the recommended temperature being 150 °C. In essence, it can be activated concurrently with chamber baking.

We are able to offer paid samples in limited quantities and for a specified duration.

Terms of supply

<u>Samples for provision</u> Limited to 100 units.

<u>Supply duration</u> From Nov. 2023 for a maximum of 2 years.

<u>Price reference</u> Kindly direct your inquires to us

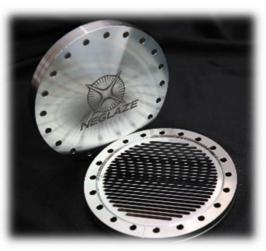
We shall furnish it to those who can furnish us

Supply terms with evaluation outcome and user reviews.

How to request samples

To request the purchase of samples, kindly specify 'Request for NEG sample' in the remarks section of the request form.





Please do NOT hesitate to contact us for any requests, estimates or inquiries here.